

"Method of Fabricating Multipole Lens, Multipole Lens, and Charged-Particle Beam Instrument Equipped Therewith"

Inventor: Eiji KAWAI  
Attorney Docket No. 116-043660

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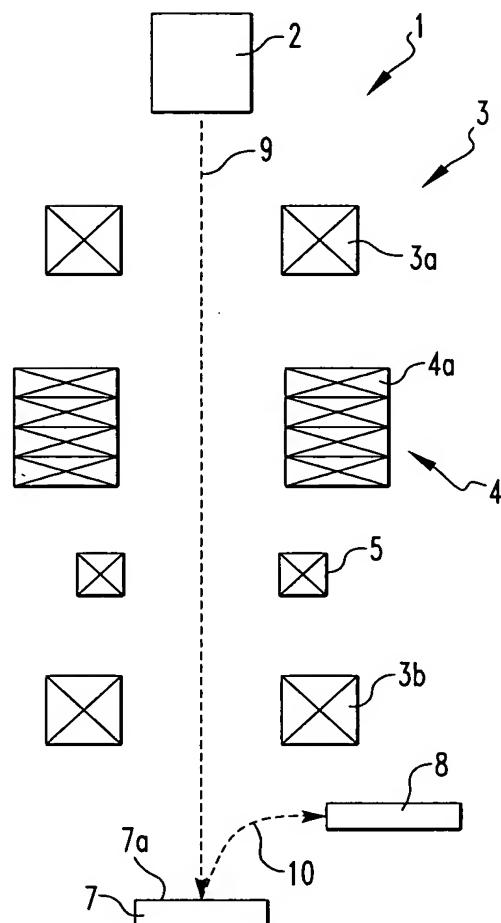


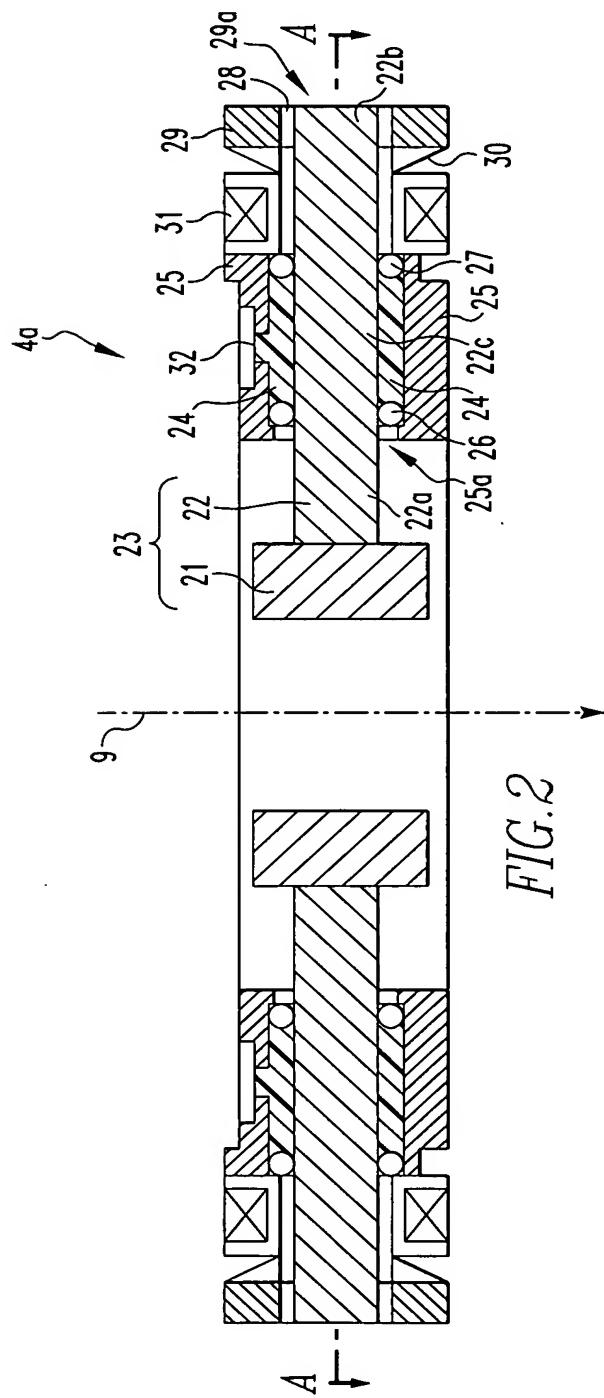
FIG.1

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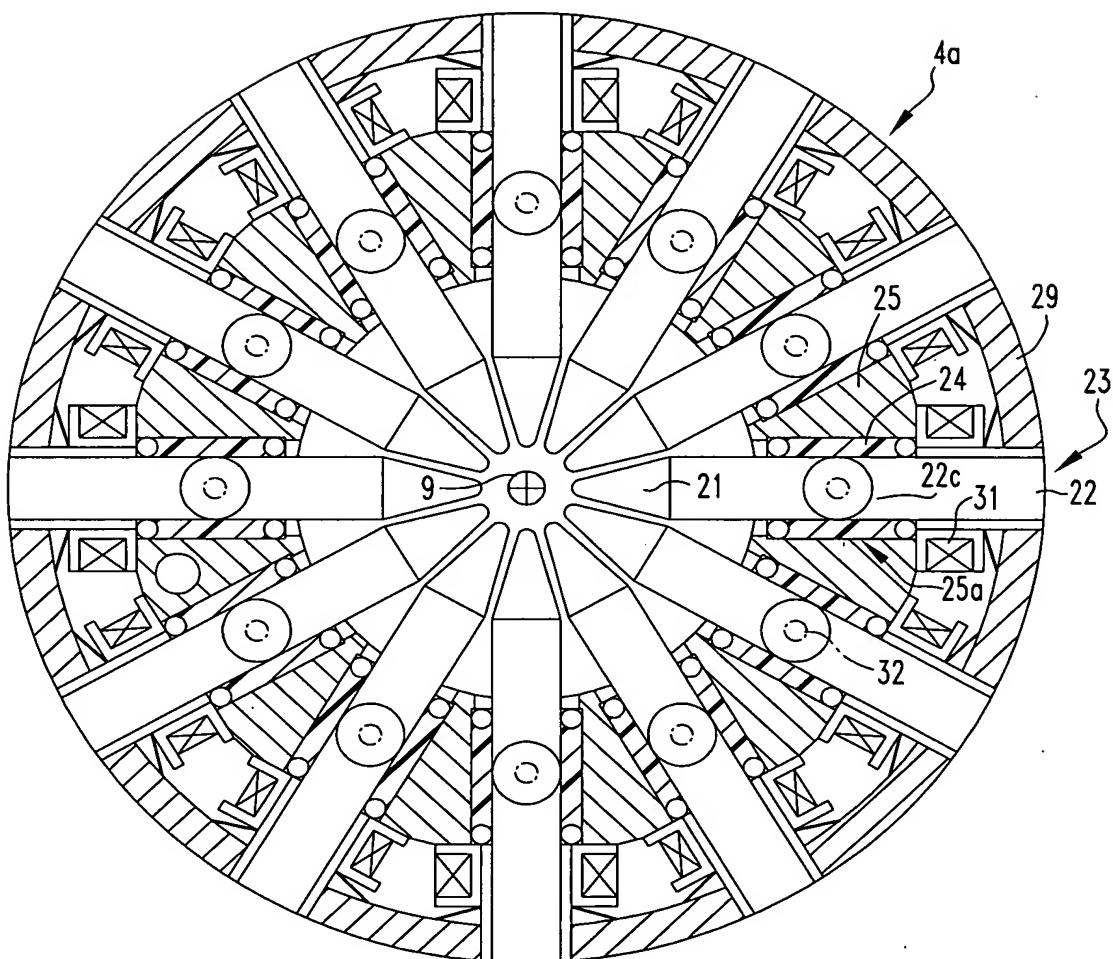


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*FIG. 3*

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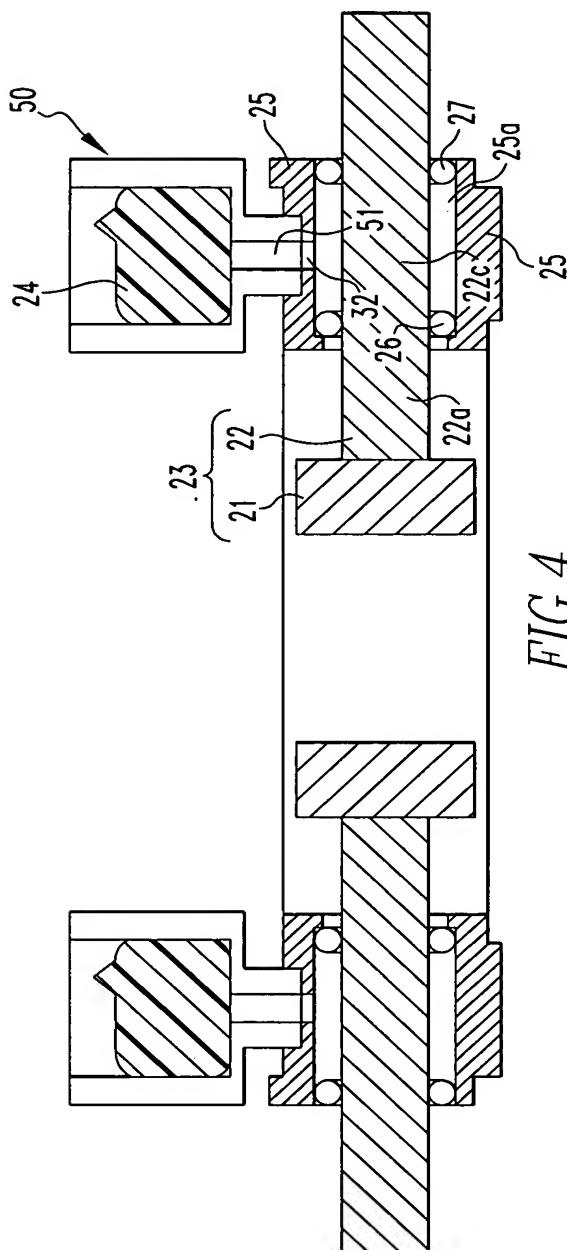
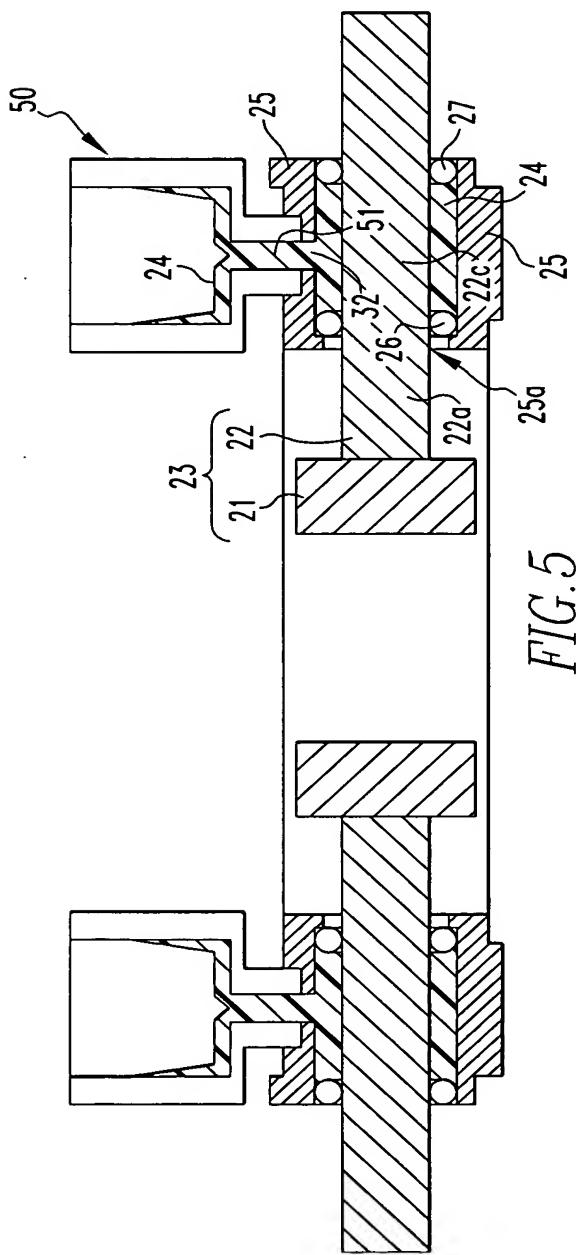


FIG. 4

"Method of Fabricating Multipole Lens, Multipole Lens, and Charged-Particle Beam Instrument Equipped Therewith"

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